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Nanostructured Thin Films X

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Editors

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Contents

v	<i>Authors</i>
vii	<i>Conference Committee</i>

STRUCTURED THIN FILMS

10356 03	Vapor and liquid optical monitoring with sculptured Bragg microcavities (Invited Paper) [10356-2]
10356 04	High efficient light absorption and nanostructure-dependent birefringence of a metal-dielectric symmetrical layered structure [10356-3]
10356 05	Third order non-linear response as function of the laser power in SiO₂:DR1 mesostructured and amorphous films [10356-4]

PLASMONICS

10356 0B	Asymmetric metal-insulator-metal (MIM) structure formed by pulsed Nd:YAG laser deposition with titanium nitride (TiN) and aluminum nitride (AlN) [10356-10]
10356 0C	An advanced plasmonic cermet solar absorber for high temperature solar energy conversion applications [10356-11]

THEORETICAL AND NUMERICAL STUDIES

10356 0F	Optical simulations of advanced light management for liquid-phase crystallized silicon thin-film solar cells (Invited Paper) [10356-14]
10356 0G	Wave front design using multiscale metasurfaces [10356-15]
10356 0H	Asymmetries in surface waves and reflection/transmission characteristics associated with topological insulators [10356-16]
10356 0I	On optical-absorption peaks in a nonhomogeneous dielectric material over a two-dimensional metallic surface-relief grating [10356-17]

FABRICATION AND FUNCTIONALIZATION

10356 0J	New generation all-silica based optical elements for high power laser systems (Invited Paper) [10356-18]
10356 0L	Optical anisotropy due to perpendicular azimuth serial bideposition [10356-20]

10356 OM **Graphene oxide reduction induced by femtosecond laser irradiation** [10356-21]

MULTIFUNCTIONAL AND HYBRID NANOSTRUCTURES

10356 ON **Zero-contrast silicon-based metasurfaces: resonance physics and applications (Invited Paper)** [10356-22]

10356 OO **Nitrogen doped silicon-carbon multilayer protective coatings on carbon obtained by TVA method** [10356-23]

10356 OQ **Advanced design of UV waveplates based on nano-structured thin films** [10356-25]

POSTER SESSION

10356 OR **Development of batch producible hot embossing 3D nanostructured surface-enhanced Raman scattering chip technology** [10356-26]

10356 OS **The thickness correction of sol-gel coating using ion-beam etching in the preparation of antireflection coating** [10356-27]

10356 OT **Transition from Dyakonov and Dyakonov-Tamm surface waves to surface-plasmon-polariton waves induced by temperature** [10356-28]

10356 OW **Non-exhibition of Bragg phenomenon by chevronic sculptured thin films** [10356-31]

10356 OZ **Photonic nanostructure design for high efficiency light absorber** [10356-34]

Authors

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Ahmad, Faiz, 0I	Magnusson, Robert, 0N
Anderson, Tom H., 0I	Mandes, Aurelia, 0O
Andrulevičius, Mindaugas, 0Q	Maragkaki, Stella, 0M
Arnold, Matthew D., 0C, 0L	Mažulė, L., 0J
Bao, Ganghua, 0S	McAtee, Patrick D., 0W
Becker, Christiane, 0F	Melninkaitis, A., 0J
Bilokur, M., 0C	Monk, Peter B., 0I
Burger, Sven, 0F	Nicolescu, Virginia, 0O
Buzelis, Rytis, 0J, 0Q	Oliva-Ramirez, Manuel, 03
Caraiane, Aureliana, 0O	Oshikane, Yasushi, 0B
Chen, Duote, 0F	Ostendorf, Andreas, 0M
Cheng, Xinbin, 0S	Porosnicu, Corneliu, 0O
Chiadini, Francesco, 0H, 0T	Salas-Gamez, G., 05
Ciupina, Victor, 0O	Scaglione, Antonio, 0H, 0T
Civiletti, Benjamin J., 0I	Selskis, Algirdas, 0J, 0Q
Cortie, M., 0C	Smith, Geoffrey B., 0C, 0L
Cupsa, Ovidiu, 0O	Tai, Matthew C., 0L
Dinca, Paul, 0O	Tolenis, Tomas, 0J, 0Q
Dinca, Virginia, 0O	Tsai, Ming-Shiuan, 0R
Drazdys, Ramutis, 0J, 0Q	Vasile, Eugeniu, 0O
Dong, Siyu, 0S	Vepachedu, Vikas, 0W
Eisenhauer, David, 0F	Vladoiu, Rodica, 0O
Felbacq, Didier, 0G	Volz, Sergej, 0M
Fiumara, Vincenzo, 0H, 0T	Xie, Lingyun, 0S
García-Macedo, J. A., 05	Wang, Zhanshan, 0S
Gentle, Angus R., 0C, 0L	Yubero, Francisco, 03
Gil-Rostra, Jorge, 03	Zaharia, Agripina, 0O
González-Elípe, Agustín R., 03	Zhang, Jinlong, 0S
Grinevičiūtė, Lina, 0J, 0Q	
Gurevich, Evgeny L., 0M	
Hammerschmidt, Martin, 0F	
He, Tao, 0S	
Huang, Chu-Yu, 0R	
Huang, Yi-Fan, 0Z	
Jäger, Klaus, 0F	
Jen, Yi-Jun, 04, 0Z	
Jepu, Ionut, 0O	
Jhang, Yi-Ciang, 04	
Jiao, Hongfei, 0S	
Kasischke, Maren, 0M	
Kling, Emmanuel, 0G	
Ko, Yeong Hwan, 0N	
Köppel, Grit, 0F	
Lakhtakia, Akhlesh, 0H, 0I, 0T, 0W	
Lazauskas, Algirdas, 0Q	
Liu, Wei-Chih, 04	
López-Santos, Maria C., 03	
Lungu, Cristian P., 0O	
Mackay, Tom G., 0H, 0T	

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- 1 Inaugural Keynote Session
Tom G. Mackay, The University of Edinburgh (United Kingdom)
- 2 Structured Thin Films
Francesco Chiadini, Università degli Studi di Salerno (Italy)
- 3 Hybrid Nanostructures
Ibrahim Abdulhalim, Ben-Gurion University of the Negev (Israel)

- 4 Plasmonics
Yi-Jun Jen, National Taipei University of Technology (Taiwan)
- 5 Theoretical and Numerical Studies
Chang Kwon Hwangbo, INHA University (Korea, Republic of)
- 6 Fabrication and Functionalization
Klaus Jäger, Helmholtz-Zentrum Berlin für Materialien und Energie GmbH (Germany)
- 7 Multifunctional and Hybrid Nanostructures
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